

PATENT ASSIGNMENT

Electronic Version v1.1

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SUBMISSION TYPE:	NEW ASSIGNMENT	
NATURE OF CONVEYANCE:	ASSIGNMENT	
CONVEYING PARTY DATA		
Name		Execution Date
Shingo HISHIYA		09/20/2005
RECEIVING PARTY DATA		
Name:	TOKYO ELECTRON LIMITED	
Street Address:	3-6, Akasaka 5-chome, Minato-ku	
City:	Tokyo	
State/Country:	JAPAN	
Postal Code:	107-8481	
PROPERTY NUMBERS Total: 1		
Property Type	Number	
Application Number:	10552993	
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NAME OF SUBMITTER:	Tirhas Gessesse	
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PATENT
REEL: 018959 FRAME: 0325

ASSIGNMENT

USP041006
(04S0314P)

In consideration of value received, I, having a mailing address at
c/o Intellectual Property Department, TOKYO ELECTRON LIMITED, 3-6 Akasaka 5-chome,
Minato-ku, Tokyo 107-8481, Japan, and a residence as stated below next to my name, the
sole inventor (if only one name is listed below) or a joint inventor (if plural inventors are
listed below) of an invention described in an application for United States patent entitled:

METHOD AND APPARATUS FOR PROCESSING ORGANOSILOXANE FILM

said application having been filed on October 13, 2005
and assigned Application No. 10/552,993
sell and assign to
TOKYO ELECTRON LIMITED
a corporation of Japan, having a business address at
3-6, Akasaka 5-chome, Minato-ku, Tokyo 107-8481 Japan

its successors, assigns or nominees, hereinafter referred to as "Assignee", my entire right,
title and interest in and to said invention as disclosed, shown and described in said
application for United States patent : (check one)

☒ [X] executed concurrently herewith;
☐ [] executed separately herefrom;

and in and to all applications for patent and patents for said invention including all
divisions, reissues, continuations, substitutions and extensions thereof and all rights
arising under or pursuant to any and all international agreements, treaties or laws relating
to the protection of industrial property, including rights of priority, resulting from the filing
of any of said applications; and I authorize and request any official whose duty is to issue
patents, to issue any patent on said invention or resulting therefrom to said Assignee, and I
agree that on request and without further consideration, but at the expense of said
Assignee, I will communicate to said Assignee or its representatives all facts known to me
respecting said invention and testify in any legal proceeding, sign all lawful papers, execute
all divisional, continuing, reissue or other applications, make all rightful oaths and
declarations, and generally do everything possible to aid said Assignee to obtain and
enforce proper patent protection for said invention in all countries.

I hereby grant the following law firm the power to insert on this Assignment any further
identification which may be necessary or desirable in order to comply with the Rules of the
U.S. Patent and Trademark Office for recordation of this document.

Oblon, Spivak, McClelland, Maier & Neustadt, P.C., 1940 Duke Street, Alexandria, VA
22314

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USP041006
(04S0314P)

Inventor: (Signature)

Date

Residence

Shingo Hishiya
Shingo Hishiya

SEP. 20. 2005

Tokyo, Japan